# Photoelectrochemistry of Semiconductor Nanowire Arrays

Thomas E. Mallouk<sup>1</sup> and Joan M. Redwing<sup>2</sup> (Primary Contacts), Sarah M. Eichfeld,<sup>2</sup> Adrian P. Goodey,<sup>1</sup> Emil A. Hernandez,<sup>1</sup> and Rui Xiao<sup>1</sup> The Pennsylvania State University Departments of Chemistry<sup>1</sup> and Materials Science and Engineering<sup>2</sup> University Park, PA 16802 Phone: (814) 863-9637, Fax: (814) 863-8403 tom@chem.psu.edu, jmr31@psu.edu

DOE Program Officer: Mark Spitler Mark.Spitler@science.doe.gov; 301 903-4568

## **Objectives**

The primary goal of this project is to explore the use of semiconductor nanowires and nanowire arrays as components of liquid-junction photoelectrochemical cells and water splitting systems. Our first objective was to control the chemical purity of nanowires grown by the vapor-liquid-solid method so as to demonstrate simple liquid-junction photoelectrochemistry with one semiconductor doping type. A more ambitious goal has been to study photochemical charge separation in axial and radial nanowire p-n junctions and heterostructures. Learning to control the composition, structure, and surface chemistry of the nanowires is an important prerequisite realizing these goals.

#### **Technical Barriers**

Efficient photoelectrochemical cells and water splitting systems have been demonstrated with semiconductors Si, InP, and CdSe as large single crystals, but the cost of single crystals is too high for practical use in solar hydrogen generation. Nanowires of the same materials can be grown as single crystals and as epitaxial heterostructures by several techniques, including chemical vapor deposition and electrodeposition. In principle, arrays of nanowires can be used to make high efficiency, low cost liquid junction solar cells and multi-bandgap electrodes for overall water splitting.

## Abstract

This project has investigated the photoelectrochemical properties of p-Si and p-InP nanowires grown by vapor phase techniques on p-Si substrates, and has developed an electrochemical method for growing crystalline nanowire arrays of CdSe nanowires in anodic alumina templates. With p-Si and p-InP nanowire photocathodes in non-aqueous electrolytes, we observe low dark currents and photovoltages in the range of 100-230 mV. Our current efforts are focused on controlling nanowire dimensions (length and diameter), surface chemistry, and bulk composition in order to improve the photoelectrochemical properties of the nanowire arrays.

## **Progress Report and Future Directions**

*Photoelectrochemistry of p-Silicon Nanowire Arrays.* Our initial work on silicon nanowire (SiNW) arrays employed porous alumina membranes as templates, and used electrodeposition methods to grown Au catalyst nanowire segments on top of Co back

contacting wires. Under vapor-liquid-solid (VLS) growth conditions, we were able to obtain crystalline Si nanowire arrays as a brush on the outer surface of the membrane, with the Co back contact buried in the alumina matrix. The nanowire diameter corresponded well to the pore size of the membranes. These experiments used SiH<sub>4</sub> as the silicon source, and trimethylboron (TMB) or phosphine as p- and n-type doping gases, respectively. Four-point probe measurements on individual nanowires showed that they were heavily p-doped even without addition of TMB. Attempts to fabricate photoelectrochemical cells resulted in identical light and dark currents, consistent with the overdoping of the nanowires.



Fig. 1. p-Si nanowire arrays grown by VLS.

Because the most likely source of adventitious p-type doping was Al from the alumina membrane, we later used crystalline p-Si substrates. Under these conditions, dense crystalline nanowire arrays were also obtained, as illustrated in Fig. 1. The nanowires that were not intentionally doped had resistivities in the range  $10^4$ - $10^5$   $\Omega$ -cm and could be doped p- and n-type by mixing TMB or phosphine with the silane source. After appropriate etches to remove the gold

catalyst tips and superficial oxide layer, these nanowire arrays gave photovoltages of 200-230 mV in nonaqueous  $[Ru(bpy)_3]^{2+}$  solutions. Under identical conditions, p-Si single crystal electrodes had photovoltages of ~500 mV and lower dark current. The scan rate of the photocurrent established that the photocurrent came from the nanowire array and not the (dark) p-Si substrate. This result is very encouraging because it shows that VLS-grown nanowire arrays function as photodiodes in liquid junction cells. It also underscores the need to understand and minimize bulk and surface recombination in these systems in order to realize efficient semiconductor nanowire array solar cells.

Growth and characterization of Si nanowires. Our initial studies demonstrated that SiNW fabricated by vapor-liquid-solid (VLS) growth using SiCl<sub>4</sub> as the silicon precursor on gold-coated (111) Si substrates had a high resistivity (400-6000  $\Omega$ -cm) indicating a background impurity level less than  $5 \times 10^{14}$  cm<sup>-3</sup> assuming bulk Si hole mobility. However, the surface of the SiNWs was found to be rough suggesting that HCl produced from the reaction of SiCl<sub>4</sub> and H<sub>2</sub> may be etching the wires during growth. In order to investigate this, nanowire growth experiments were carried out to study the effect of temperature and SiCl<sub>4</sub> partial pressure (P<sub>SiCl4</sub>) on the growth rate and structural properties of the nanowires. The SiNW growth rate was found to be strongly dependent on the SiCl<sub>4</sub> partial pressure (P<sub>SiCl4</sub> was increased from 1.6 to 3.6 Torr, the SiNW growth rate increased linearly with P<sub>SiCl4</sub> reaching a maximum of 7 µm/min at P<sub>SiCl4</sub>=4 Torr. As the P<sub>SiCl4</sub> was increased further, however, the growth rate dropped significantly. The experimental results were compared to the predicted mass of solid silicon formed as a function of P<sub>SiCl4</sub> using a gas phase equilibrium model of the SiCl<sub>4</sub>/H<sub>2</sub> system at temperatures ranging from 1050-1100°C. The thermodynamic model predicted a similar

maximum in Si solid phase formation and revealed that at high  $P_{SiCl4}$ , the SiCl<sub>4</sub>/H<sub>2</sub> gas phase equilibrium transitions into an etching regime where the formation of gaseous SiCl<sub>x</sub> species becomes thermodynamically favored. These results also suggest that gas phase thermodynamics controls the growth of Si nanowires in the SiCl<sub>4</sub>/H<sub>2</sub> system.<sup>1</sup>

Structural characterization of the Si nanowires grown using SiCl<sub>4</sub> revealed that there was no gold catalyst present on the SiNW tips suggesting that gold diffusion was occurring at 900°C during nanowire growth and/or cool-down from the growth temperature. Subsequent studies determined that the Au diffusion was occurring primarily during the cool-down step. Field emission scanning electron microscopy (FESEM) revealed that samples slowly cooled (15°C/min) had small amounts of Au or no Au present on the SiNW tip, while a fast cool-down (50°C/min) left a larger portion of the Au tip intact. Transmission electron microscopy (TEM) of the SiNWs revealed the absence of a native oxide layer on the nanowire surface suggesting that the surfaces are passivated by either hydrogen or chlorine during growth. These results are consistent with *in-situ* studies of Kodambaka *et al.*<sup>2</sup> where significant gold diffusion was observed to occur during nanowire growth on hydrogen-passivated SiNW surfaces at low growth rates under ultrahigh vacuum conditions. Our results reveal that substantial gold diffusion can also occur after growth for SiNWs grown at much higher pressures and growth rates.<sup>3</sup>

*Electrodeposition of CdSe Nanocrystal Arrays.* We have also developed a topochemical cation exchange route to obtain vertical arrays of crystalline CdSe nanowires (CdSeNW). The process begins by electrodeposition of amorphous Se in the pores of alumina membranes. The membranes are then partially etched with to expose the wires for reaction with Cd(NO<sub>3</sub>)<sub>2</sub>. Currently, the problem we have is that the polysulfide electrolyte used for CdSe photoelectrochemistry is basic and etches the membrane. We have recently initiated a collaboration with Dr. Alvin Compaan at the University of Toledo to sputter a thick layer of CdSe onto the membranes for back contact. Once we have addressed the back contact problem we will study the photelectrochemical properties of the nanowire arrays in liquid- and polymer-junction cells.



Fig. 1. p-InP nanowires grown on p-Si(111).

*Photoelectrochemistry* p-InP of Nanowires. p-type InP is a very interesting photoelectrode material because it has a nearly ideal bandgap (1.4 eV). Single-crystal p-InP electrodes can attain photovoltages in the range of 0.8 V in liquidjunction cells, and can be catalyzed to act as photocathodes for hydrogen evolution from water. We have collaborated with Robyn Woo and Prof. Robert Hicks at UCLA, who have developed a metal-organic vapor phase epitaxy (MOVPE)

method for growing InP nanowires on p-Si(111) surfaces from trimethylindium and tri-*t*-butylphosphine. Under the right growth conditions, dense arrays of single crystal nanowires can be obtained (Fig. 2). Our preliminary photoelectrochemical measurements

gave promising results in non-aqueous methylviologen electrolytes, as shown in Fig. 3. The nanowire arrays have relatively low dark current, and in the light show photovoltages



in the range of 100 mV. Again, this is an encouraging preliminary result because the growth conditions, nanowire dimensions, and surface chemistry are not yet optimized.

Fig. 3. Cyclic voltammetry (50 mV/s) of a Pt disk electrode and a InP NW array photocathode under white light illumination and in the dark.

Our future work with these nanowire systems will concentrate on understanding and minimizing bulk and surface carrier recombination. One parameter that is readily controllable is the nanowire diameter. Recent studies by Kayes et al.<sup>4</sup> suggest that the

diffusion length of minority carriers in p-SiNW should be large relative to the diameters we have studied to date. Increasing the diameter should decrease the surface-to-volume ratio and thereby affect the rate of surface recombination. Following up on our results in the p-Si (SiH<sub>4</sub>/TMB) system, are also studying the effect of doping and nanowire composition (as determined by choice of VLS catalyst) on dark current density and photoelectrochemical properties.

## **References**

1. S.M. Eichfeld and J.M. Redwing, "Thermodynamic limitations on the growth of Si nanowires using  $SiCl_4$ ", manuscript in preparation.

2. S. Kodambaka, J.B. Hannon, R.M. Tromp, and F.M. Ross, "Control of Si nanowire growth by oxygen", Nano Letters 2006, 6, 1292-1296

3. S.M. Eichfeld, Q. Zhang, E.C. Dickey and J.M. Redwing, "Post-growth catalyst diffusion in Si nanowires grown by vapor-liquid-solid growth," manuscript in preparation.

4. B. M. Kayes, H. A. Atwater, and N. S. Lewis, J. Appl. Phys. 2005, 97, 114302.

#### Publications (including patents) acknowledging the grant or contract

1. S.M. Eichfeld, T.T. Ho, C.M. Eichfeld, A. Cranmer, S.E. Mohney, T.S. Mayer and J.M. Redwing, "Resistivity measurement of undoped and intentionally doped template-grown silicon nanowire arrays," Nanotechnol. 18 (2007) p. 315201.

2. A. P. Goodey, S. M. Eichfeld, K.-K. Lew, J. M. Redwing, and T. E. Mallouk, "Silicon nanowire array photoelectrochemical cells," J. Am. Chem. Soc. 124, 12344-12345 (2007).

3. R.L. Woo, Y. Kobayashi, L. Gao, M. Jackson, T. E. Mallouk, M. Goorsky, and R.F. Hicks, "Self-catalytic growth of InP nanowires on Si (100) substrates by metalorganic vapor phase epitaxy," in preparation.